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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Saeko KURACHI

Application No.: New U.S. Patent Application

Filed: March 4, 2002

Docket No.: 111204



For: CARBON MONOXIDE SELECTIVE OXIDIZING CATALYST AND
MANUFACTURING METHOD FOR THE SAME

INFORMATION DISCLOSURE STATEMENT

Director of the U.S. Patent and Trademark Office
Washington, D.C. 20231

Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. Relevance of the non-English language reference 1 is discussed in the present specification.
- ☒ 3. A concise explanation of the relevance of the non-English language references appears in the Appendix attached hereto.
- ☒ 4. English-language Abstracts of the non-English language references are attached hereto.

Respectfully submitted,

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List of Related Art for IDS

Japanese Patent Publication	File Date	Publication Date	Comments
JP(P) HEI11-347414	1998/06/10	1999/12/21	Described in the specification.
JP(P) HEI09-320624	1996/07/05	1997/12/12	The background of the present invention is described in the JP(P) HEI09-320624.
JP(P) HEI11-130406	1997/10/23	1999/05/18	The background of the present invention is described in the JP(P) HEI11-130406.